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Information Disclosure Statement PTO-1449 (Modified)

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APR 0 9 2002 55	Atty. Docket No.:	Serial No.: 10/082,712
LIST OF PATENTS AND PUBLIC PROPERTY OF APPLICANT'S SUPPLEMENTAL SURMISSION OF ART	Applicants: Pramod K.	Arora
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## Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.

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SUPPLEMENTAL SUBMISSION OF ART (Use several sheets if necessary)

Atty. Docket No.: ICTP101US

Serial No.:

10/082,712

Applicants: Pramod K. Arora

Filing Date: February 25, 2002

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	5	1	0	6_	5	6	1	4/21/92	Singh et al.	264	165	
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